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10/080884  
02/22/02

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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10080884	02/22/2002	438	704	1765	Deo

\*\*APPLICANTS: Kim Do-Hyung; Kim Sung-Bong; Hong Jung-In;

\*\*CONTINUING DATA VERIFIED:  
*gd*

\*\* FOREIGN APPLICATIONS VERIFIED:

REPUBLIC OF KOREA 2001-09381 02/23/2001  
*gr*

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials		<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <i>gr</i>
ATTORNEY DOCKET NO 4591-226		
TITLE : Method of forming a device isolation trench in an integrated circuit device U.S.DEP.T. OF COMM./PAT.& TM-PTO-436L(Rev. 12-94)		

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg.	Print Fig.
TERMINAL DISCLAIMER		Application Examiner		
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